

Notice of References Cited	Application/Control No. 10/569,171		Applicant(s)/Patent Under Reexamination THEEUWEN ET AL.	
	Examiner Anthony Ho		Art Unit 2815	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,545,316	04-2003	Baliga, Bantval Jayant	257/329
*	B	US-2002/0102800	08-2002	Van Den Heuvel, Renerus Antonius	438/301
*	C	US-6,448,611	09-2002	Oh, Han-Su	257/340
*	D	US-6,870,219	03-2005	Brech, Helmut	257/340
*	E	US-5,514,608	05-1996	Williams et al.	438/286
*	F	US-6,063,678	05-2000	D'Anna, Pablo Eugenio	438/301
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.